Docket No.: FIS920000301US1 CBLH/20136-00326-US1 (PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Marie Angelopoulos, et al.

Application No.: TBA

Art Unit: 1752

Filed: Herewith

Examiner: R. Ashton

For: RADIATION SENSITIVE SILICON-

CONTAINING NEGATIVE RESISTS AND

USE THEREOF

## PRELIMINARY AMENDMENT

## MS PATENT APPLICATION

September 9, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

Prior to examination on the merits and calculation of any fees for excess claims, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification begin on page 2.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.